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-	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/711,618	KE ET AL.
	Examiner	Art Unit
	Jeffrey L. Sterrett	2838

SEARCHED			
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
323	273	6/7/2006	JLS		
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SEARCH NOT (INCLUDING SEARCH) .
	DATE	EXMR
Interference search history printout	6/7/2006	JLS
Update search	6/7/2006	JLS
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